

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **RALPH KURT, MICHAEL CORNELIS VAN BEEK,
ANTONIE ELLERT DUISTERWINKEL,
ERIK RENE KIEFT,
HANS MEILING,
BASTIAAN MATTHIAS MERTENS,
JOHANNES HUBERTUS JOSEPHINA MOORS,
LUCAS HENRICUS JOHANNES STEVENS, and
BASTIAAN THEODOOR WOLSCHRIJN**

Application No.: **TO BE ASSIGNED**

Confirmation
No:

Filed: February 23, 2004

Group No.:
Examiner

For: **METHOD AND DEVICE FOR MEASURING CONTAMINATION OF A SURFACE OF A
COMPONENT OF A LITHOGRAPHIC APPARATUS**

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

**APPLICATION DATA SHEET
37 C.F.R. § 1.76**

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: **RALPH KURT**
Citizenship: **GERMANY**
Residence: **Allersma 48, NL-5655 CG Eindhoven, The Netherlands**

Second applicant: **MICHAEL CORNELIS VAN BEEK**
Citizenship: **THE NETHERLANDS**
Residence: **Vluttersven 11, NL-5646 HX Eindhoven, The Netherlands**

Third applicant: **ANTONIE ELLERT DUISTERWINKEL**
Citizenship: **THE NETHERLANDS**
Residence: **Molukkenstraat 10, NL-2612 EC Delft, The Netherlands**

Fourth applicant: **ERIK RENE KIEFT**
Citizenship: **THE NETHERLANDS**
Residence: **Aurorastraat 4, NL-5631 KK Eindhoven, The Netherlands**

Fifth applicant: **HANS MEILING**
Citizenship: **THE NETHERLANDS**
Residence: **Parklaan 76, NL-3722 BG Bilthoven, The Netherlands**

Sixth applicant: **BASTIAAN MATTHIAS MERTENS**
Citizenship: **THE NETHERLANDS**
Residence: Snelliusstraat 90, NL-2517 RK Den Haag, The Netherlands

Seventh applicant: **JOHANNES HUBERTUS JOSEPHINA MOORS**
Citizenship: **THE NETHERLANDS**
Residence: Dierdonkiaan 56, NL-5709 MT Helmond, The Netherlands

Eighth applicant: **LUCAS HENRICUS JOHANNES STEVENS**
Citizenship: **THE NETHERLANDS**
Residence: Grassijsje 15, NL-5658 EE Eindhoven, The Netherlands

Ninth applicant: **BASTIAAN THEODOOR WOLSCHRIJN**
Citizenship: **THE NETHERLANDS**
Residence: Zeeburgerdijk 558, NL-1059 AM Amsterdam, The Netherlands

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: **METHOD AND DEVICE FOR MEASURING CONTAMINATION
OF A SURFACE OF A COMPONENT OF A LITHOGRAPHIC APPARATUS**

Docket number assigned to this application: 081468-0308336

Suggested Classification: Class:
Subclass:
Technology Center to which subject matter is assigned:

Total number of drawing sheets: 6

Type of application: Utility

Application is to be published. Suggested drawing figure for publication: **FIGURE 2**

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: EUROPE
Application No.: 03075548.2
Filing Date: February 24, 2003

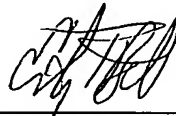
6. Assignee information

The assignee(s) of this application is/are:

ASML NETHERLANDS B.V.
De Run 6501, NL-5504 DR Veldhoven, The Netherlands
Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: February 23, 2004

PILLSBURY WINTHROP LLP
P.O. Box 10500
McLean, VA 22102
Customer No. 00909



Signature of Practitioner
Emily T. Bell
Registration No. 47418
(703) 905-2261